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Docket No.: M4065.0609/P609-D
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jiutao Li

Application No.: 10/758,009

Confirmation No.: 6261

Filed: January 16, 2004

Art Unit: 2811

For: AGGLOMERATION ELIMINATION FOR
METAL SPUTTER DEPOSITION OF
CHALCOGENIDES

Examiner: Not Yet Assigned

STATUS INQUIRY

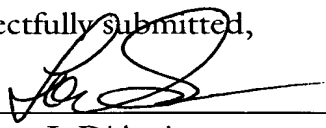
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: January 14, 2005

Respectfully submitted,

By 

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